

Docket No. 251219US2DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Shoichi HARAKAWA, et al.

SERIAL NO: NEW DIVISIONAL APPLICATION

FILED: HEREWITH

FOR: SEMICONDUCTOR PROCESSING PROCESS CONTROL SYSTEM AND ITS CONTROL METHOD

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ The applicant(s) wishes to make of record the references listed on the attached PTO-1449 form. Copies of the listed references were made of record in parent application serial no. 09/606,173, filed February 29, 2000, as were either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
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Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 251219US2DIV		SERIAL NO. NEW DIV APPLICATION	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Shoichi HARAKAWA, et al.			
				FILING DATE HEREWITH		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	5,740,065	04/14/1998	YOUNG-CHUL JANG ET AL			
	AB	5,694,325	12/1997	FUKUDA ET AL			
	AC	6,399,511	06/2002	TANG ET AL			
	AD	6,385,496	05/2002	IRWIN ET AL			
	AE	6,263,255	07/2001	TAN ET AL			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	8-45804	02/16/1996	JAPAN (Corresponding U.S. 5,740,065)		X	
	AP	6-196404	07/15/1994	JAPAN (w/English Abstract)		X	
	AQ	10-256241	09/25/1998	JAPAN (w/English Abstract)		X	
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Etsuo FUKUDA, et al., "Advancd Process Control System Description of an Easy-To-Use Control System Incorporating Pluggable Modules," IEEE INTERNATIONAL SYMPOSIUM ON SEMICONDUCTOR MANUFACTURING, June 1999, pgs. 321-324.					
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							